

In re: Thomas A Rinehart et al.  
Application No.: 10/661,916  
Filed: September 11, 2003  
Page 2 of 3

**In the Specification:**

Page 1, lines 2-11, please amend the "Cross-Reference to Related Applications" paragraph as follows:

This application is related to Application Serial No.            10/661,917 entitled *Systems and Methods For Mastering Microstructures Through a Substrate Using Negative Photoresist and Microstructure Masters So Produced* (~~Attorney Docket No. 9409-3~~) to the present inventors, filed concurrently, and Application Serial No.            10/661,974, entitled *Systems and Methods For Fabricating Microstructures By Imaging A Radiation Sensitive Layer Sandwiched Between Outer Layers, and Microstructures Fabricated Thereby* (~~Attorney Docket No. 9409-4~~) to the present inventors, also filed concurrently, both of which are assigned to the assignee of the present application, the disclosures of both of which are hereby incorporated herein by reference in their entirety as if set forth fully herein.